

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q66559

Akira OOSAWA

Appln. No.: 09/988,658

Group Art Unit: 2624

Confirmation No.: 8995

Examiner: Chong R KIM

Filed: November 20, 2001

For: METHOD AND APPARATUS FOR DETECTING ANOMALOUS SHADOWS

STATEMENT OF SUBSTANCE OF INTERVIEW

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please review and enter the following remarks summarizing the interview conducted on
October 25, 2007:

REMARKS

An Examiner's Interview Summary Record (PTO-413) was attached with the Notice of
Allowance dated November 5, 2007.

During the interview, the undersigned discussed with the Examiner the rejections of
record and possible amendments to place the application in condition for allowance. In
the interest of allowing the application to issue in an expedited fashion, Applicant
consented to certain claim changes. Applicant does not waive the right to pursue broader
subject matter.

It is respectfully submitted that the instant STATEMENT OF SUBSTANCE OF
INTERVIEW complies with the requirements of 37 C.F.R. §§1.2 and 1.133 and MPEP §713.04.

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It is believed that no petition or fee is required. However, if the USPTO deems otherwise, Applicant hereby petitions for any extension of time which may be required to maintain the pendency of this case, and any required fee, except for the Issue Fee, for such extension is to be charged to Deposit Account No. 19-4880.


Respectfully submitted,

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WASHINGTON OFFICE

23373

CUSTOMER NUMBER


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Date: December 5, 2007